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**Control Vision Talks 2020 – Call for Papers/Presentations**

**PRESS RELEASE**  
  
for immediate release

**EMVA welcomes submissions to forum for Machine Vision & Optical Metrology**

*Barcelona/Stuttgart, 23 January, 2020*. With their continued partnership Control show organizer P.E. Schall and the EMVA enable another edition of the successful EMVA lecture forum “Control Vision Talks 2020” around the 34th Control from 5 - 7 May 2020 in Stuttgart. Embedded into the trade show in hall 8 the presentations of this forum for Machine Vision & Optical Metrology aim to educate the trade show visitor on benefits, applications and methods of machine vision and optical metrology solutions for factory automation.

The talks will be held in German or English language and will present technology background as well as dedicated solutions going way beyond mere marketing-oriented product presentations. Towards this goal each of the three first trade show days will feature presentations for a dedicated technology topic. We hereby offer companies or individuals the opportunity to give a free-of-charge 20-minute presentation during the Control Vision Talks 2020 on one of the following topics:

* 3D Machine Vision (Tuesday, May 5th)
* Optical Metrology: Offline to Inline (Wednesday, May 6th)
* CT and X-ray (Thursday, May 7th)
* Spectral Imaging: From Infrared to Hyperspectral (Thursday, May 7th)

The focus of the presentation should either be fundamentals or new technologies. Pure product presentations cannot be considered when selecting the program. Applications need to include the following information:

* Presentation title
* Lecture block (3D, Optical Metrology, CT/X-ray or Spectral Imaging)
* short abstract (approx. 1,000 to 2,000 characters, not words)
* Language: English or German

Please send your application to vision-talks@emva.org or use the following page for submitting your papers: emva.org/events/other/control-vision-talks-2020. The deadline for paper submission is February 10th, 2020.

**About the European Machine Vision Association**

The EMVA is a not for profit organization, open to all, which is owned by its members who represent over 120 companies, institutes, and organizations, originating from within Europe, North America, and Asia. The association seeks to represent the interests of its members and promote the vision industry in general, but also encourage cooperation and standardization. The EMVA hosts several important standards used throughout the machine vision industry including the GenICam series used to provide a consistent, device independent interface to machine vision hardware, the EMVA1288 standard used for bench-marking performance of industrial cameras, and the newly initiated Open Optics Camera Interface (OOCI) standard which addresses the connectivity of camera lenses within a machine vision system, and the new emVISION initiative addressing standardization within embedded vision systems. To find out more visit the web site www.emva.org.